



RECEIVED

JUL 14 2003

TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AI- 11746

#9
AS

7/16/3

In re the Application of: **Yuji ONO et al.**

Group Art Unit: 1746

Serial No.: 09/940,788

Examiner: **Joseph L. Perrin**

Filed: **August 29, 2001**

P.T.O. Confirmation No.: 4613

For. **SINGLE WAFER TYPE SUBSTRATE CLEANING METHOD AND APPARATUS**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 9, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated March 11, 2003 for one month from June 11, 2003 to July 11, 2003.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Daniel A. Geselowitz, Ph.D.

Agent for Applicants

Reg. No. 42,573

DAG/plb
Atty. Docket No. **011075**
Suite 1000
1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



23850

PATENT TRADEMARK OFFICE